



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Eun-sung LEE, et al.

Art Unit: 2811

Serial No.: 10/773,312

Examiner: C.Q. Nguyen

Filed: February 9, 2004

Confirmation No. 6650

For: MEMS DEVICE AND FABRICATION METHOD THEREOF

**SECOND PRELIMINARY AMENDMENT AND RESPONSE TO ELECTION
REQUIREMENT**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

In response to the Office action mailed October 2, 2006, and prior to examination on the merits, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims are reflected in a listing of claims, which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.